

Germany-Cologne: Laboratory, optical and precision equipments (excl. glasses)

OJ S 198/2023 13/10/2023

Contract notice

Supplies

Legal Basis:

Directive 2014/24/EU

Section I: Contracting authority

I.1. Name and addresses

Official name: Deutsches Zentrum für Luft- und Raumfahrt e.V. (DLR)

Postal address: Linder Höhe

Town: Köln

NUTS code: DEA23 Köln, Kreisfreie Stadt

Postal code: 51147

Country: Germany

E-mail: babette.wegener@dlr.de

Telephone: +49 2203/601-5184

Internet address(es):

Main address: http://www.dlr.de/DE/Home/home_node.html

I.3. Communication

The procurement documents are available for unrestricted and full direct access, free of charge, at: <https://www.subreport.de/E26541969>

Additional information can be obtained from the abovementioned address

Tenders or requests to participate must be submitted to the abovementioned address

I.4. Type of the contracting authority

Other type: Forschungseinrichtung

I.5. Main activity

Other activity: Forschungseinrichtung

Section II: Object

II.1. Scope of the procurement

II.1.1. Title

Laborausrüstung Innovationszentrum HH | Ion Beam Etching

II.1.2. Main CPV code

38000000 Laboratory, optical and precision equipments (excl. glasses)

II.1.3. Type of contract

Supplies

II.1.4. Short description

Zur Strukturierung insbesondere von metallischen Schichten wird eine Anlage zum Ionenstrahlätzen (ion beam etching IBE) benötigt. Diese soll als Prozesse auch das reaktive Ionenstrahlätzen (reactive ion beam etching RIBE) und das chemisch unterstützte

Ionenstrahlätzen (chemically assisted ion beam etching CAIBE) unterstützen. Mit den Verfahren sollen unter anderem Au, Al und SiO₂ Dünnschichten auf 150 mm Wafern mittels Lackmaske strukturiert werden.

II.1.5. Estimated total value

II.1.6. Information about lots

This contract is divided into lots: no

II.2. Description

II.2.3. Place of performance

NUTS code: DE Deutschland

II.2.4. Description of the procurement

Zur Strukturierung insbesondere von metallischen Schichten wird eine Anlage zum Ionenstrahlätzen (ion beam etching IBE) benötigt. Diese soll als Prozesse auch das reaktive Ionenstrahlätzen (reactive ion beam etching RIBE) und das chemisch unterstützte Ionenstrahlätzen (chemically assisted ion beam etching CAIBE) unterstützen. Mit den Verfahren sollen unter anderem Au, Al und SiO₂ Dünnschichten auf 150 mm Wafern mittels Lackmaske strukturiert werden.

Auftragsgegenstand

- Anlage gemäß Spezifikation inkl. Lieferung, Inbetriebnahme, Abnahme und Schulung
- Service und Wartung gemäß Spezifikation

Detaillierte Beschreibung in Anlage 01 Leistungsbeschreibung (LB IBE) in den Vergabeunterlagen.

II.2.5. Award criteria

Criteria below

Quality criterion - Name: Qualität / Weighting: 30 %

Quality criterion - Name: Service und Lieferung / Weighting: 20 %

Price - Weighting: 50 %

II.2.6. Estimated value

II.2.7. Duration of the contract, framework agreement or dynamic purchasing system

Duration in months: 60

This contract is subject to renewal: no

II.2.10. Information about variants

Variants will be accepted: no

II.2.11. Information about options

Options: no

II.2.13. Information about European Union funds

The procurement is related to a project and/or programme financed by European Union funds:
no

II.2.14. Additional information

Section III: Legal, economic, financial and technical information

III.1. Conditions for participation

III.1.1. Suitability to pursue the professional activity, including requirements relating to enrolment on professional or trade registers

List and brief description of conditions:

Handelsregisterauszug nicht älter als 3 Monate bei Angebotsabgabe

III.1.2. Economic and financial standing

Selection criteria as stated in the procurement documents

III.1.3. Technical and professional ability

Selection criteria as stated in the procurement documents

III.2. Conditions related to the contract

III.2.2. Contract performance conditions

vgl. Vergabeunterlagen und Anlage 01 Leistungsbeschreibung

Section IV: Procedure

IV.1. Description

IV.1.1. Type of procedure

Open procedure

IV.1.3. Information about a framework agreement or a dynamic purchasing system

IV.1.8. Information about the Government Procurement Agreement (GPA)

The procurement is covered by the Government Procurement Agreement: no

IV.2. Administrative information

IV.2.2. Time limit for receipt of tenders or requests to participate

Date: 08/11/2023 Local time: 14:00

IV.2.3. Estimated date of dispatch of invitations to tender or to participate to selected candidates

IV.2.4. Languages in which tenders or requests to participate may be submitted

German

IV.2.6. Minimum time frame during which the tenderer must maintain the tender

Tender must be valid until: 15/12/2023

IV.2.7. Conditions for opening of tenders

Date: 08/11/2023 Local time: 14:15

Section VI: Complementary information

VI.1. Information about recurrence

This is a recurrent procurement: no

VI.2. Information about electronic workflows

Electronic ordering will be used

Electronic invoicing will be accepted

Electronic payment will be used

VI.3. Additional information

vgl. Vergabeunterlagen Anlage 02 Aufforderung zur Angebotsabgabe, sowie weitere Vergabeunterlagen.

VI.4. Procedures for review**VI.4.1. Review body**

Official name: Vergabekammer des Bundes

Postal address: Villemombler Straße 76

Town: Bonn

Postal code: 53123

Country: Germany

E-mail: vk@bundeskartellamt.bund.de

Telephone: +49 22894990

Fax: +49 2289499163

Internet address: <http://www.bundeskartellamt.de>

VI.5. Date of dispatch of this notice

08/10/2023